L Number	Hits	Search Text	DB	Time stamp
1	612	438/166.ccls.	USPAT	2004/06/30 14:11
2	240	438/482.ccls.	USPAT	2004/06/30 14:11
3	366	438/486.ccls.	USPAT	2004/06/30 14:12
4	332	438/487.ccls.	USPAT	2004/06/30 14:12
5	362	438/488.ccls.	USPAT	2004/06/30 14:12
6	92	lin-kun$.in.	USPAT	2004/06/30 14:13
7	34	lin-kun$.in.	US-PGPUB	2004/06/30 14:12
8	14	lin-kun$.in.	EPO; JPO; DERWENT; IBM_TDB	2004/06/30 14:12
9	16061	amorph$6 and laser and crystal$9	USPAT	2004/06/30 14:17
10	11247	(amorph$6 and laser and crystal$9) and (amorph$6 same crystal$9)	USPAT	2004/06/30 14:14
11	5712	((amorph$6 and laser and crystal$9) and (amorph$6 same crystal$9)) and (laser same crystal$9)	USPAT	2004/06/30 14:15
12	4207	(((amorph$6 and laser and crystal$9) and (amorph$6 same crystal$9)) and (laser same crystal$9)) and (polysilicon silicon)	USPAT	2004/06/30 14:16
13	3926	((((amorph$6 and laser and crystal$9) and (amorph$6 same crystal$9)) and (laser same crystal$9)) and (polysilicon silicon)) and (etch$6 mask$6 cap$9)	USPAT	2004/06/30 14:16
14	1576	(((((amorph$6 and laser and crystal$9) and (amorph$6 same crystal$9)) and (laser same crystal$9)) and (polysilicon silicon)) and (etch$6 mask$6 cap$9)) and excimer	USPAT	2004/06/30 14:17
15	5604	amorph$6 and laser and crystal$9 and (silicon polysilicon)	US-PGPUB	2004/06/30 14:18
16	1640	(amorph$6 and laser and crystal$9 and (silicon polysilicon)) and excimer	US-PGPUB	2004/06/30 14:17
17	1520	amorph$6 and laser and crystal$9 and (silicon polysilicon)	EPO; JPO; DERWENT; IBM_TDB	2004/06/30 14:18